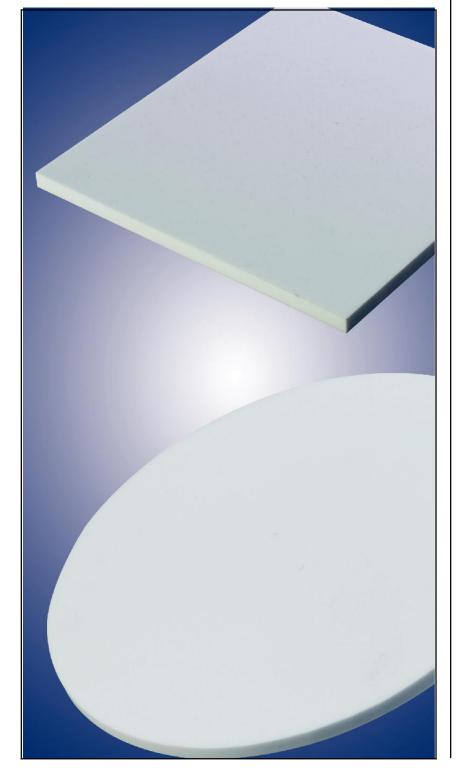
Lithium Orthophosphate

MEM

Li₃PO₄ Sputtering Targets



Applications

 Reactively deposited in partial pressure of nitrogen to produce LIPON (lithium phosphorous oxynitride)

Advanced Engineering Materials

Electrolyte layer in rechargeable thin film batteries

Features

- High purity
- High density
- Stoichiometric
- Phase pure
- · Homogenous

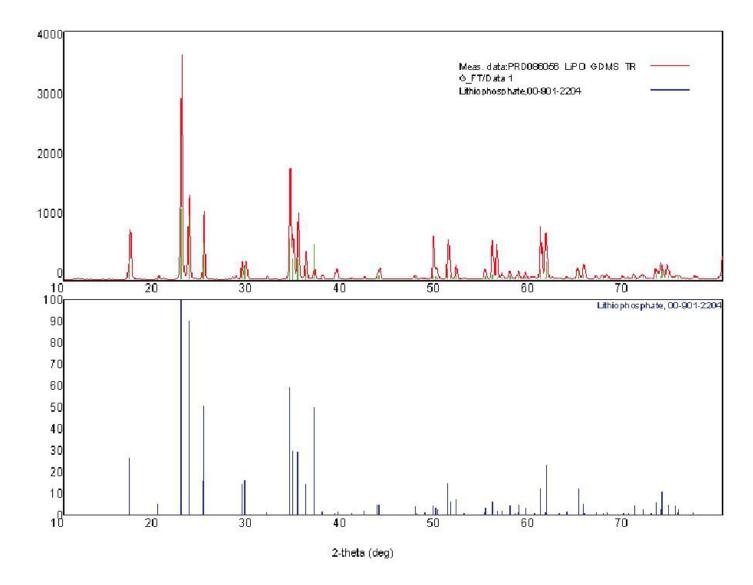
Manufacturing Process

- In-house powder synthesis
- High purity precursor materials
- Wet chemistry process utilized for powder synthesis
- High energy mixing
- Specially formulated calcination schedule
- Particle sizing processes
- · Multiple step densification
 - Proprietary processes employed for pressing and sintering
- · Cleaning and final packaging
 - Cleaned for use in vacuum
 - Protection from environmental contaminants
 - Protection during shipment

Options

- · 99.95% purity
- Custom compositions may be available upon request
- Circular targets up to 12" (300 mm) diameter
- Planar tiles up to 8" (250 mm) X 5" (125 mm) for larger target configurations
- Smaller sizes also available for R&D applications
- · Sputtering target bonding service

X-Ray Diffraction Pattern of Sintered Li₃PO₄ Sputtering Target



Specifications

Typical Analysis - 99.95% (3N5) Purity

Metallic Impurities, ppm by weight

Al	Ва	Со	Cr	Fe	Mg	Мо	Na	Ni	Si	Zn	Zr
<30	<10	<10	<110	<160	<5	<5	<10	<50	<50	<10	<50

Theoretical Density	2.46 g/cm₃				
Relative Density	2.26 g/cm₃ minimum				
Appearance	White, may have blue spots				

Advanced Engineering Materials

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